

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application		OFGS File No. P/4309-64			
		Applicant Miroslav KOSTKA et al.					
		Filing Date Herewith		Group Art Unit --			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-5,719,360	2/1998	STONE et al.				
	US-4,838,385	6/1989	EKHOLM				
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	WO 02 14198	2/2002	PCT			n/a	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	PATENT ABSTRACTS OF JAPAN, vol. 017, no. 343 (M-1436), 29 June 1993 & JP 05 043142 A (Fujitsu Ltd), 23 February 1993 *Abstract*.						
	PATENT ABSTRACTS OF JAPAN, vol. 018, no. 245 (M-1603), 11 May 1994 & JP 06 032544 A (Toshiba Corp), 8 February 1994 *Abstract*.						
Examiner		Date Considered 3/28/06					
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